



GAU 2653

Dkt. 0980/63993

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Technology Center 2600

APR 03 2001

#3 RECEIVED

Application of : Hwan JEONG, et al.

Serial No. : 09/765,544

Group Art Unit: 263

Date Filed : January 19, 2001

Examiner:

For : OPTICAL INTERLEAVING WITH ENHANCED SPECTRAL
RESPONSE AND REDUCED POLARIZATION SENSITIVITY1185 Avenue of the Americas
New York, N.Y. 10036Assistant Commissioner for Patents
Washington, D.C. 20231**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Sir:

Pursuant to Applicants' duty of disclosure, the information listed in the attached form PTO-1449 is brought to the attention of the Examiner. A copy of the information identified herein is also provided.

It is respectfully requested that the information cited in annexed Form PTO-1449 be considered by the Examiner in connection with the above-identified patent application, and that such art be made of record in said application.

I hereby certify that this paper is being deposited this date with the
U.S. Postal Service as first class mail addressed to the Assistant
Commissioner for Patents, Washington, D.C. 20231.

Ivan S. Kavrukov
Ivan S. Kavrukov
Reg. No. 25,161

Mar 28, 2001
Date

HA

The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that these items are prior art. The items listed are submitted in good faith, but are not intended to substitute for the Examiner's search. It is hoped, however, that in addition to apprising the Examiner of the particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.

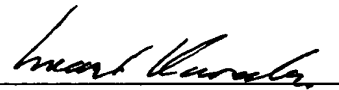
The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

To the best of Applicant(s) knowledge, this Information Disclosure Statement is being filed before the date of mailing of a first Office Action on the merits in connection with this case.

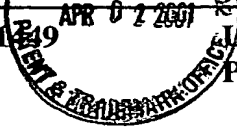
The Office is hereby authorized to charge any fees that may be required for consideration of this Information Disclosure Statement and to credit any overpayment to our Deposit Account No. 03-3125.

Early and favorable consideration of the case is respectfully requested.

Respectfully submitted,



Ivan S. Kavrukov
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Attorney for Applicants
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 <p>Form PTO-1349</p> <p>U.S. Department of Commerce Patent and Trademark Office</p> <p align="center">INFORMATION DISCLOSURE CITATION BY APPLICANT</p> <p align="center">(Use several sheets if necessary)</p>	<p>Atty. Docket No. 0980/63993</p>	<p>Serial No. 09/765,544</p>
<p>Applicant Hwan J. JEONG, et al.</p>		
<p>Filing Date January 19, 2001</p>		<p>Group 2633</p>

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
AA						
AB						
AC						
AD						
AE						
AF						
AG						
AH						
AI						
AJ						
AK						

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FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Subclass	Translation	
					Yes	No
AL WO 01 0 1 5 8 5	01/04/00	PCT				
AM						
AN						
AO						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AP	
AQ	

EXAMINER	DATE CONSIDERED
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.